



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q68832

Yasuhiro ONO, et al.

Appln. No.: 10/091,531 ✓

Group Art Unit: 1756 ✓

Confirmation No.: 8361

Examiner: Kathleen DUDA

Filed: March 7, 2002

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DEC 29 2003
TC 1700

For: METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE HAVING A RUTHENIUM OR A RUTHENIUM OXIDE

REQUEST FOR RECONSIDERATION

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated September 29, 2003, please consider the remarks as submitted herewith on the accompanying pages.

REMARKS

Applicant thanks the Examiner for acknowledging the claim for priority under 35 U.S.C. § 119 and receipt of the priority document.

The Office Action Summary (PTO-326) indicates on its face that the Office Action contains copies of the initialed Information Disclosure Statements on form PTO-1449 filed March 7, 2002 (paper no. 2). However a copy of initialed paper 2 was not included with the copy of the September 29, 2003 Office Action received by applicants' representative. It is respectfully requested that the Examiner forward to applicants' representative copies of the form